

Ryoto Takizawa

Inorganic Materials Research Section, Materials Research Dept., TOTO LTD.

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■ PERSONAL STATEMENT

I am engaged in material design and process design related to AD method since joining the company.

■ EDUCATION

MA in Science

Nagoya University, Aichi Prefecture, Japan

May 2016

BA in Science

Nagoya University, Aichi Prefecture, Japan

2014

■ PROFESSIONAL SOCIETIES

2014 – 2016, The Physical Society of Japan

2018 – present, The Ceramic Society of Japan (CerSJ)

2019 – present, The Japan Institute of Electronics Packaging (JIEP)

■ CONFERENCE PRESENTATIONS

“Evaluation for microstructure and material properties of Zirconia coatings by AD method,”

PACRIM 13, Convention center, Okinawa, Japan, October 2019.

“Particle contamination Evaluation for Plasma resistance components,” 33th JIEP Spring

Symposium, Takushoku University, Tokyo, Japan, May 2019

“Heat dissipation characteristics of Zirconium Oxide film prepared by Aerosol Deposition Method,”

31th CerSJ Autumn Symposium, Nagoya Institute of Technology, Aichi, Japan, September 2018.

■ HONORS AND PRIZES

Research incentive award at 33th JIEP Spring Symposium

May 2020